Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/675,561	VISHLITZKY ET AL.	
Examiner	Art Unit	
Hong C. Kim	2185	

SEARCHED					
Class	Subclass	Date	Examiner		
ciph	5a	5/22/06	(SL		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EHST	5/22/06	(SL		